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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

Application No.: 10/053,160

) Date: July 18, 2003

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Applicant: Tsai-Yu Huang

) Examiner: Lan Vinh

)

Group Art Unit 1765

Filed: 01/15/2002

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) Our Ref: 619445-9 B-4453

For: "A Method of Etching A Mask
Layer ..."

)

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

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JUL 24 2003
GROUP 1700

Sir:

This paper is filed in response to the Office Action dated April 18, 2003. **All amendments and remarks herein are made without prejudice.**